1-31-01

Docket No.: 49959-118 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Lizhong Sun, et al.

Serial No.: 09/645,690 -

Filed: August 24, 2000 ~

For: CU CMP POLISHING PAD CLEANING _

Group Art Unit: 2812

Examiner: unknown

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to pending applications Serial No. 09/163,582 and Serial No. 09/359,141, which contain similar subject matter to the above-referenced application. A reference cited in these applications is listed on the attached form PTO-1449.

The identification of these U.S. Patent Applications is not to be construed as a waiver of secrecy as to that application now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination.

09/645,690

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael A. Messina Registration No. 33,424

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 MAM:brd

Date: January 23, 2001 Facsimile: (202) 756-8087